INFORMATION DISCLOSURE STATEMENT Sheet 1 of 1 ATTY DOCKET NO. FORM PTO 1449 (modified) 2005_0321A U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE **APPLICANT** Yuichiro SASAKI et al. LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) GROUP FILING DATE Date Submitted to PTO: April 27, 2005 April 27, 2005 U.S. PATENT DOCUMENTS FILING DATE IF APPROPRIATE SUBCLASS DOCUMENT NUMBER DATE NAME CLASS *EXAMINER INITIAL AA AB AC AD ΑE AF AG AΗ ΑI FOREIGN PATENT DOCUMENTS COUNTRY CLASS SUBCLASS **TRANSLATION** DATE DOCUMENT YES NO NUMBER abstract 1-16-98 AIC S 10-12890 Japan AJ 11-22-00 Europe X ΑK 1 054 433 abstract 2002-170782 6-14-02 Japan ΑL abstract wo 02/080254 10-10-02 AM abstract 2.21A AN 2000-114198 4-21-00 Japan OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.) Bunji MIZUNO et al., "Plasma Doping into the Side-Wall of a Sub-0.5 µm Width Trench", Extended Abstracts of AO AKS the 19th Conference on Solid State Devices and Materials, Tokyo, 1987, pp. 319-322 AP AQ 90 DATE CONSIDERED

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